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To the Honorable Commissioner of Patents and Tradema	arks: Please record the att	ached original doo	cuments or copy	thereof.
1. Name of conveying party(ies): <u>3.19.0</u> Tadahiro OHMI , Takahisa NITTA, Yasuyuki SHIRAI,	4 2. Name and an Name: <u>Tada</u>	ddress of recei ahiro OHMI		· …
Osamu NAKAMURA		ress:	Komegabukuro	2-chome
	Aoba-ku, S	Sendai-shi, Miy		
Additional name(s) of conveying party(ies) attached? Yes				
3. Nature of conveyance:	Name: Stella	a Chemifa Kab	ushiki Kaisha	l
Assignment Merger	Street Addre	ess: 6-3, Awajir	nachi 3-chome	э,
Security Agreement Change of Nam	e)saka-shi, Osak		
Other				
	City:	St	ate:Zip:_	
02-27-2004 Execution Date:	Additional name	e(s) & address(es)	attached?	
If this document is being filed together with a new a A. Patent Application No.(s)				
A. Patent Application No.(s)	B. Patent No	o.(s)		
A. Patent Application No.(s)	B. Patent No	D.(S) No		
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CONTRACTOR AND A DECEMBER OF A

PATENT REEL: 015128 FRAME: 0702

ASSIGNMENT

WHEREAS, Tadahiro OHMI, residing at residing at I-17-301, Komegabukuro 2-chome Aoba-ku. Sendai-shi. Miyagi-ken 980-0813 JAPAN. and Kabushiki Kaisha L Jitraclean Technology Research Institute, having a place of business located at Kabushiki Kaisha Ultraclean Technology Research Institute, 1-4 Hongo 4-chome, Bunkyo-ku, Tokyo 113-0033 JAPAN, in consideration of the sum of ONE DOLLAR (\$1.00) to us in hand paid, and for other good and valuable consideration, the receipt and sufficiency whereof is hereby acknowledged, Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute do hereby assign, sell, transfer and set over unto said Tadahiro OHMI, residing at residing at 1-17-301, Komegabukuro 2-chome Aoba-ku, Sendai-shi, Miyagi-ken 980-0813 JAPAN, and Stella Chemifa Kabushiki Kaisha, having a place of business located at 6-3, Awajimachi 3-chome, Chuo-ku, Osaka-shi, Osaka 541-0047, JAPAN, their successors and assigns, the full, entire and exclusive right, title and interest, for the territory of the United States of America and for all foreign countries, in and to the following;

U.S. Patent No. 6,220,500 issued on April 24, 2001, and

U.S. Patent Application No. 09/748,883 filed on December 27, 2000,

(herein referred to as invention), as described in the application identified above, and in and to said application and any divisions or continuations or continuations-in-part thereof or continuation prosecution applications or substitutes therefor which may be filed, and in and to any patents or reissues, renewals or extensions thereof which may be granted on said application or for said invention, and in and to any patent application which may be **filed** on said invention in countries foreign to the United States of America and any patents granted thereon; said invention, applications, and Letters Patent to be held and enjoyed'by said Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha, and Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha, to the full end of the term or terms for which said Letters Patent may be

Page 1 of §

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granted, as fully and entirely as the same would have been held by Tadahiro OHMI and Kabushiki Kalsha Ultraclean Technology Research Institute had this assignment not been made.

Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute hereby authorizes and requests the Patent and Trademark Office officials in the United States of America and the Patent Office officials of any and all foreign countries to issue any and all of said Letters Patent, when granted to said Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha, as the assignees of our entire right, title and interest in and to the same, for the sole use and enjoyment of said Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha, Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha=s successors and assigns.

Further. Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute agrees to execute all papers and to give such lawful testimony and to perform such other lawful acts as said Tadahiro OHMI and Stella Chemifa Kabushiki Kaisha, Tadohiro OHMI and Stella Chemifa Kabushiki Kaisha, Tadohiro OHMI and Stella Chemifa Kabushiki Kaisha successors and assigns may require to enable it or them to procure Letters Patent on said invention or reissues or extensions thereof in the United States of America and/or in any foreign country, and/or to hold, enforce or convey said Letters Patent, reissues or extensions.

Frecuted this 27th day of <u>February</u>, 2004 Taduks Plusnic Joniguli

Tadahiro OHMI

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2004. By:Yoriyuk MURAKAWA

Title:PRESIDENT For; Kabushiki Kaisha Ultraclean Technology Research Institute

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ASSIGNMENT

WHEREAS, we, Tadahiro OHMI, Takahisa NITTA, Yasuyuki SHIRAI, and Osamu NAKAMURA residing at 1-17-301, Komegabukuro 2-chome Aoba-ku, Sendai-shi, Miyagi-ken 980-0813 JAPAN, c/o Kabushiki Kaisha Ultraclean Technology Research Institute, 1-4 Hongo 4chome, Bunkyo-ku, Tokyo 113-0033 JAPAN, 2-11-305, Yagiyama Honcho 2-chome, Taihaku-ku, Sendai-shi, Miyagi-ken, 982-0801 JAPAN, and 34-3-401, Yagiyama Honcho 1-chome Taihaku-ku, Sendai-shi, Miyagi-ken, 982-0801 JAPAN have invented certain improvements in:

> WELDING METHOD FOR FLUORINE-PASSIVATED MEMBER FOR WELDING, FLUORINE-PASSIVATION METHOD

described and claimed in an application for Letters Patent of the United States of America thereon, said application having been filed on August 7, 1998, based on Japanese Application 9-227121

AFTER BEING WELD, AND WELDED PARTS

and Japanese Application 9-322361.

WHEREAS, Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, is to acquire the entire right, title and interest in and to said invention and said application for Letters Patent;

NOW, THEREFORE, in consideration of the sum of ONE DOLLAR (\$1.00) to us in hand paid, and for other good and valuable consideration, the receipt and sufficiency whereof is hereby acknowledged, we do hereby assign, sell, transfer and set over unto said Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, their successors and assigns, the full, entire and exclusive right, title and interest, for the territory of the United States of America and for all foreign countries, in and to said invention, as described in the

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PATENT REEL: 015128 FRAME: 0704 application identified above, and in and to said application and any divisions or continuations or continuations-in-part thereof or continuation prosecution applications or substitutes therefor which may be filed, and in and to any patents or reissues, renewals or extensions thereof which may be granted on said application or for said invention, and in and to any patent application which may be filed on said invention in countries foreign to the United States of America and any patents granted thereon; said invention, applications, and Letters Patent to be held and enjoyed by said Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, and their successors or assigns, to the full end of the term or terms for which said Letters Patent may be granted, as fully and entirely as the same would have been held by us had this assignment not been made.

We hereby authorize and request the Patent and Trademark Office officials in the United States of America and the Patent Office officials of any and all foreign countries to issue any and all of said Letters Patent, when granted to said Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, as the assignee of our entire right, title and interest in and to the same, for the sole use and enjoyment of said Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, their successors and assigns.

Further, we agree to execute all papers and to give such lawful testimony and to perform such other lawful acts as said Tadahiro OHMI and Kabushiki Kaisha Ultraclean Technology Research Institute, their successors and assigns may require to enable it or them to procure Letters Patent on said invention or reissues or extensions thereof in the United States of America and/or in

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PATENT REEL: 015128 FRAME: 0705

any foreign country, and/or to hold, enforce or convey said Letters Patent, reissues or extensions.

Executed this $\underline{\mathcal{A}}$ day of _____ Sep. 1998.

Tadahiro OHMI

Jasuyuki Ahirai Yasuvuki SHIRAI

hisa NITTA

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RECORDED: 03/19/2004